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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Michael J. Scaggs

Application No.: 09/733,874

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For: 157 NM LASER SYSTEM AND
METHOD FOR MULTI-LAYER
SEMICONDUCTOR FAILURE
ANALYSIS

Confirmation No.: 3133

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Examiner: Jose R. Diaz

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CERTIFICATE OF MAILING
I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope, addressed to: Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450 on May 14, 2004.
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